

[0019] In preferred embodiments, decorative layers 22,24, 26,28 comprise organic decorative materials, for example, screen printed inks, epoxies, and ultraviolet curable materials. Other decorative materials, including inorganic materials, can be used, as well. The various decorative layers can be substantially opaque, translucent, or substantially transparent. In embodiments having viewing window 14, any decoration located within the area of viewing window 14 preferably is substantially transparent so that a user can view a display (not shown) that might be mounted behind viewing window 14 or so that backlighting can be penetrate viewing window 14. Further, decoration located within the area of viewing window 14 can be selected to have certain optical properties so that such decoration acts as an optical filter.

[0020] Layer 30 is an optional, substantially transparent layer of conductive material. Referring to FIG. 3, transparent conductive layer 30, when used, preferably is configured as transparent electrodes and electrical circuit traces 32. Transparent electrodes and traces 32 can be located anywhere on substrate 28. For example, transparent electrodes and traces 32 can be located on decorated portions of substrate 18, between substrate 18 and the decoration, such the decoration is viewable through transparent electrodes and traces 32. In applications using backlighting, transparent electrodes and traces 32 can be used in backlit portions to allow the backlighting to reach the user without occlusion as would be the case if electrodes and traces 32 were made of a conventional, opaque material. Referring to FIG. 1, it can be particularly desirable to use transparent electrodes and traces 32 to embody reconfigurable keys 16 or other keys located in the area corresponding to viewing window 14 so that the output of a display (not shown) mounted behind viewing window 14 is visible to the user.

[0021] As discussed further below, electrical circuit components can be coupled to transparent electrodes and traces 32 to form field effect sensors, capacitive sensors, or other sensors. Transparent conductive layer 30 can be applied in various ways. For example, transparent conductive layer 30 can be deposited in a desired pattern using screen printing or micro-deposition techniques. Alternatively, transparent conductive layer 30 can be plated or applied as a thin film utilizing, for example, sputtering or thermal evaporation techniques, and then patterned and etched to yield transparent electrodes and traces 32. Other suitable techniques, for example, spin coating, also can be used to apply transparent conductive layer 30, as would be known to one skilled in the art.

[0022] FIG. 2 illustrates transparent conductive layer 30 disposed onto decorative layer 28, which ultimately is disposed on substrate 20. Alternatively, transparent conductive layer 30 can be disposed directly onto substrate 20. In such an embodiment, a decorative layer (not shown) optionally can be disposed on transparent conductive layer 30. In embodiments where transparent conductive electrodes and traces 32 are disposed above or below one or more decorative layers, at least the portions of such decorative layers that are coextensive with transparent conductive layer 30 preferably are substantially transparent and can comprise material having optical filtering properties. Preferred materials for transparent conductive layer 30 include, for example, inorganic materials, such as indium tin oxide, or organic materials, such as Baytron PEDOT.

[0023] Layer 40 is a layer of conventional conductive material disposed on transparent conductive layer 30. Preferably, conventional conductive material layer 40 is made of a polymer thick film silver or copper epoxy, such as that supplied by Acheson Colloids Company of Port Huron, Michigan. In other embodiments, this layer can be made of plated copper or other conductive material. Referring to FIG. 4, conventional conductive layer material 40 preferably is arranged in the form of field effect sensor electrodes 42, electrical circuit traces 44, and bonding pads 46. As discussed further below, electrical circuit components, for example, integrated circuits, transistors, and resistors (not shown), can be coupled to electrodes 42 and traces 44 via bonding pads 46 to form field effect sensors, capacitive sensors, or other sensors. Preferably, such components are connected to bonding pads using conventional soldering techniques. Alternatively, such connections can be made using conductive adhesives, anisotropic adhesives, or other suitable means, as would be known to one skilled in the art. Conventional conductive material layer 40 can be applied using any suitable technique as would be known to one skilled in the art, for example, any of the techniques discussed above in connection with the application of optional transparent conductive layer 30.

[0024] Referring to FIGS. 2 and 5, layer 50 is a solder mask/dielectric layer disposed on conventional conductive layer 40 and/or transparent conductive layer 30. Layer 50 provides a solder mask, leaving exposed the portions of conductive layer 40 to which electrical circuit components are to be bonded. For example, solder mask 50 can be designed to leave exposed bonding pads 46 to facilitate bonding of integrated circuits and other electrical components to bonding pads 46. In this manner, field effect sensors or other sensors corresponding to keys 16,18 can be constructed in situ on substrate 20. Although it generally is not preferred to couple such circuit components directly to transparent conductive layer 30, solder mask layer 50 can be designed to leave exposed portions of transparent conductive layer, as necessary, to facilitate such bonding.

[0025] Layer 50 also can provide electrical insulation between conventional conductive material layer 40 and transparent conductive layer 30 and further layers of keypad 10. For example, a particular circuit design might require the use of crossovers 70, as illustrated in FIG. 7 and as would be known to one skilled in the art. If layer 50 is selected to have suitable dielectric properties, such crossovers can be applied over layer 50 and bonded at the appropriate points to conventional conductive layer 40 (and/or transparent conductive layer 30, as necessary). In such embodiments, layer 50 insulates crossovers 70 from portions of conventional conductive layer 40 (and/or transparent conductive layer 30, as necessary) which crossovers 70 otherwise would contact, causing the potential for short circuits.

[0026] Layer 60 is an optional dielectric layer that can be used in embodiments involving crossovers 70. As discussed above in connection with layer 50, optional dielectric layer 60 provides electrical insulation between electrical crossovers and conductive portions of keypad 10 to be bridged by such crossovers.

[0027] A reconfigurable display (not shown) can be disposed on the rear side of keypad 10 adjacent the area corresponding to viewing window 14, allowing a user to